


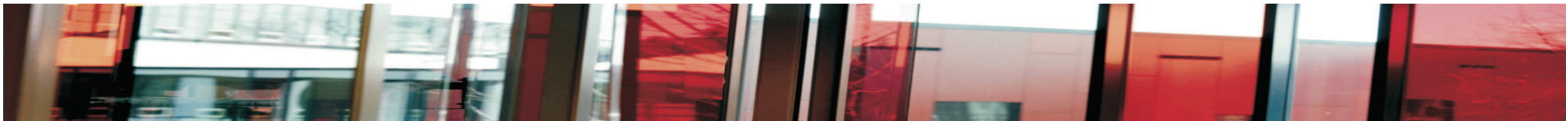
## Enhanced Thermoelectric Energy Conversion by Advanced Thin Film Technology



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*<https://people.utwente.nl/m.huijben>*

**Prof. dr. Mark Huijben**

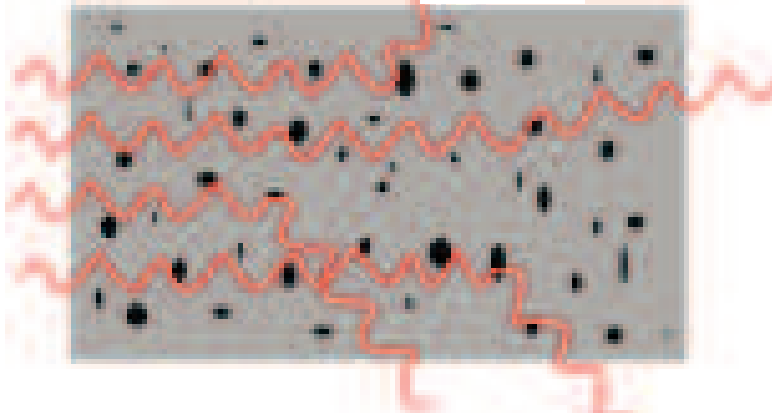
*MESA+ Institute for Nanotechnology*  
University of Twente, The Netherlands



# Controlled scattering at thin film interfaces

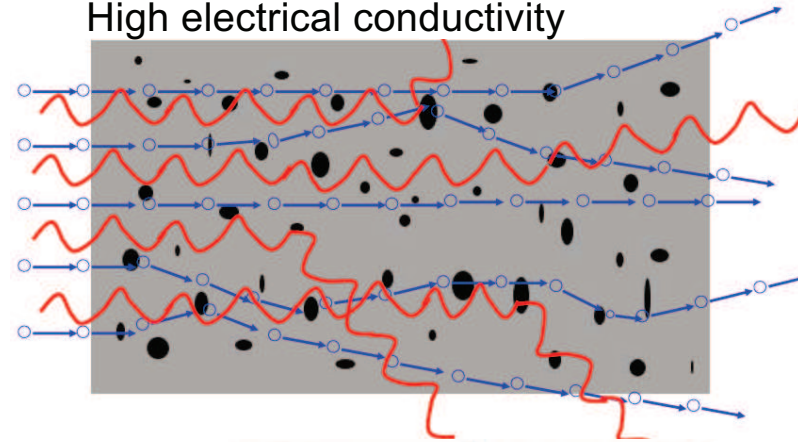
## Phonons scatter at the interfaces

Low thermal conductivity

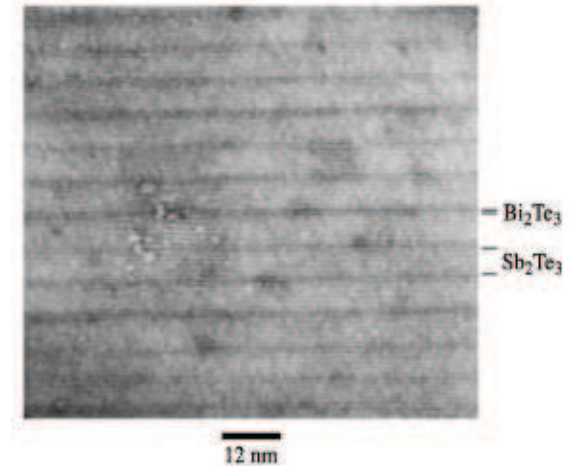
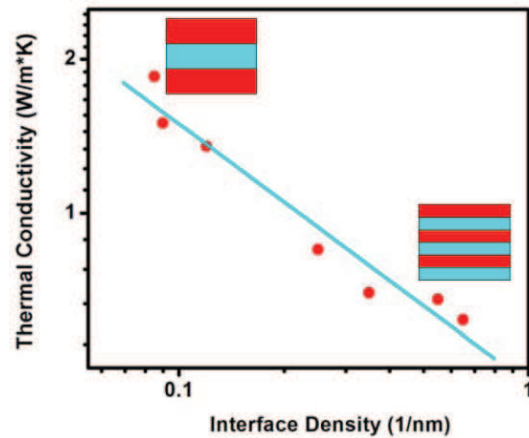


## Electrons hardly see the interfaces

High electrical conductivity



Reduced thermal conductivity



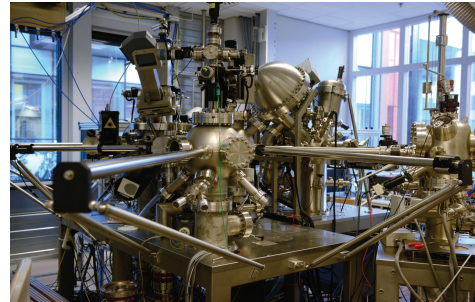
Venkatasubramanian, *Nature* **413**, 597 (2001).

# University of Twente: MESA+ Nanolab

## Unique expertise : Epitaxial thin film technology

### Aim:

Novel properties and functionalities by atomic level engineering of complex functional oxide materials



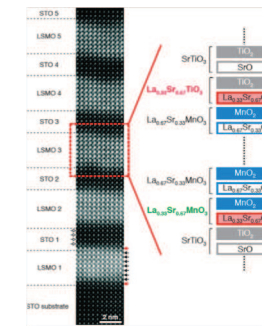
### Pulsed laser deposition

(shared research facility at Nanolab)  
9 PLD systems with variable:

- in-situ characterization tools (RHEED, XPS, XPD, UPS, STM, AFM)
- dimensions (0.5 - 20 cm diameter = 8 inch industrial Si wafers)

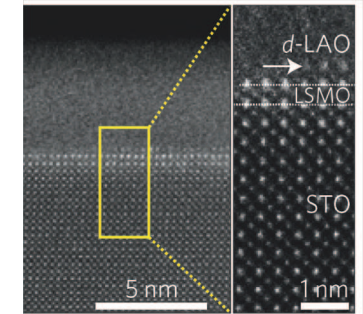
### Examples of interface engineering by Huijben *et al.*:

#### Enhanced local magnetization



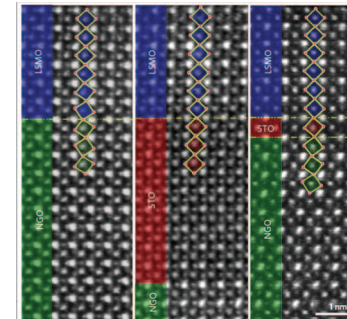
Adv. Mater. Interf. 2, 1400416 (2015)

#### Extreme mobility enhancement



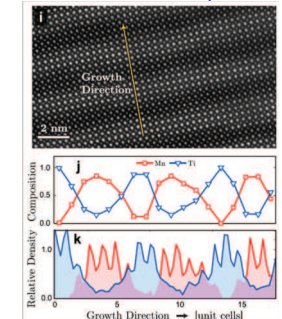
Nature Materials 14, 801 (2015)

#### Controlled octahedral rotations

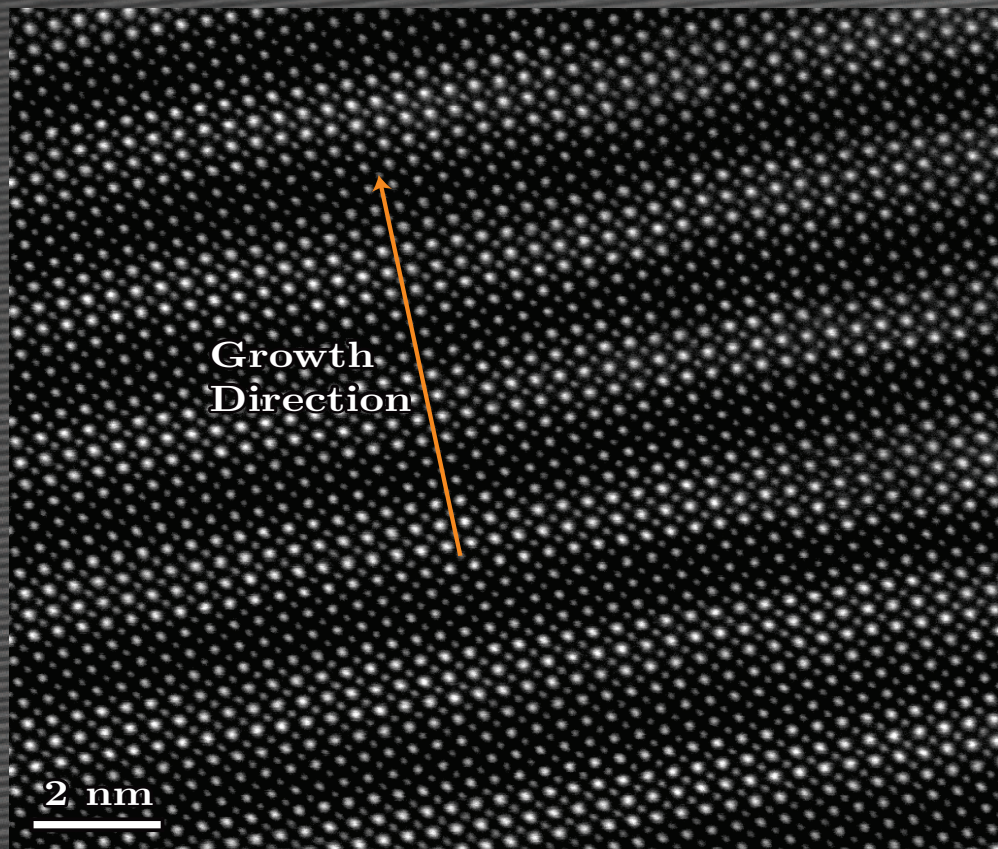


Nature Materials 15, 425 (2016)

#### Atomic-scale composition

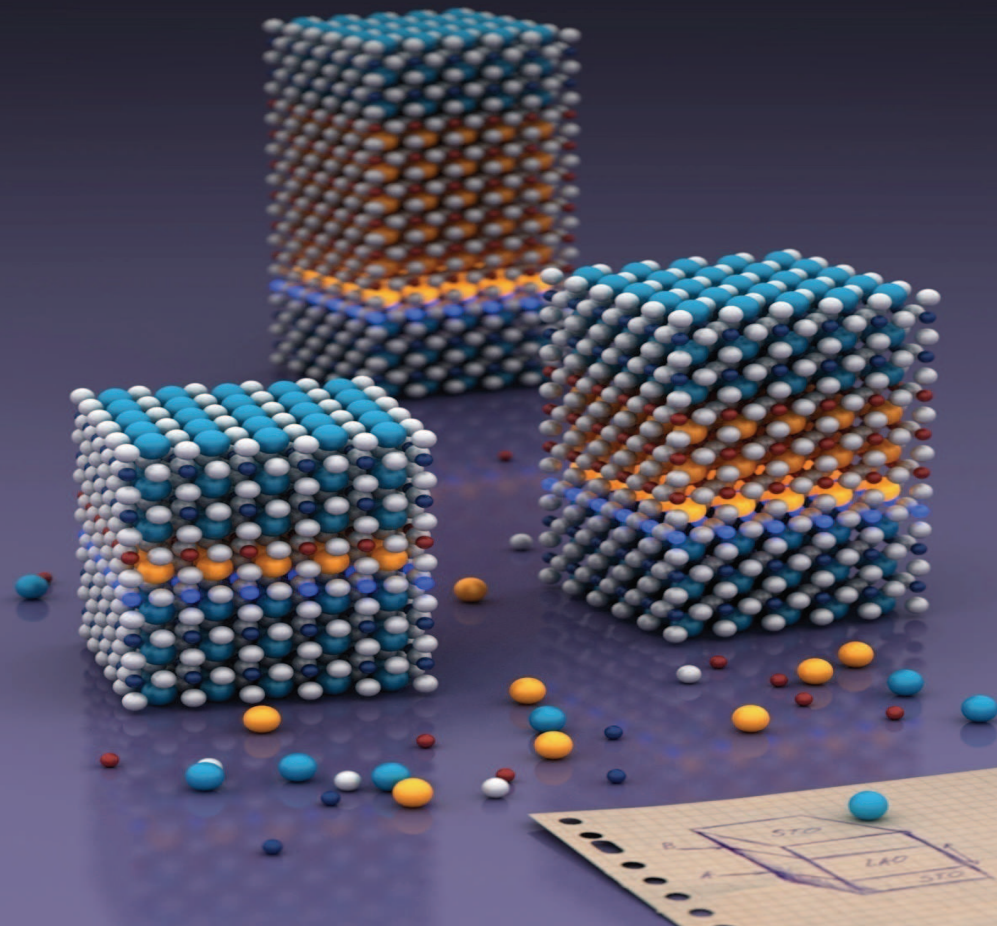


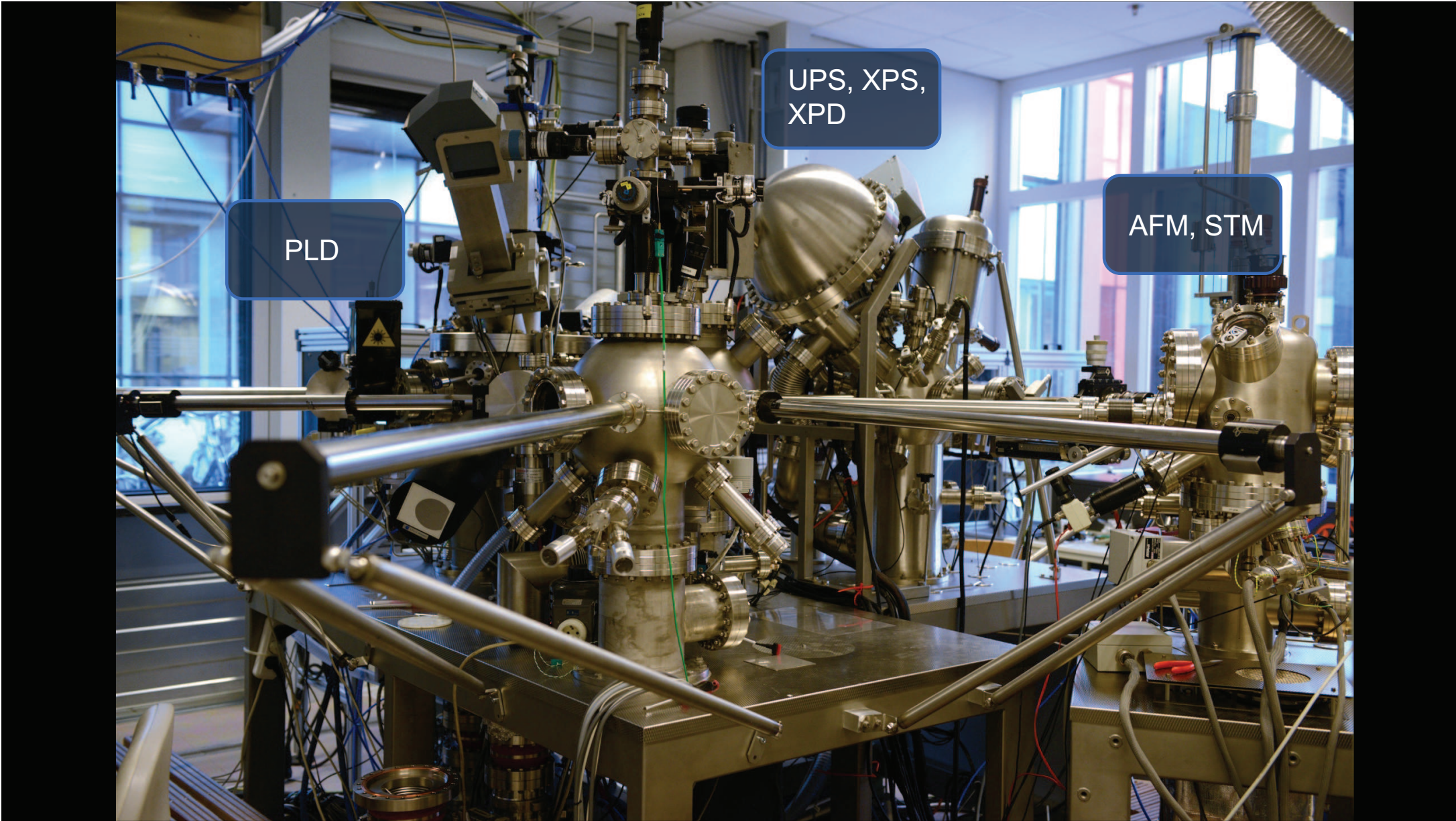
Appl. Phys. Lett. 110, 063102 (2017)



50 nm

Playing LEGO on atomic scale

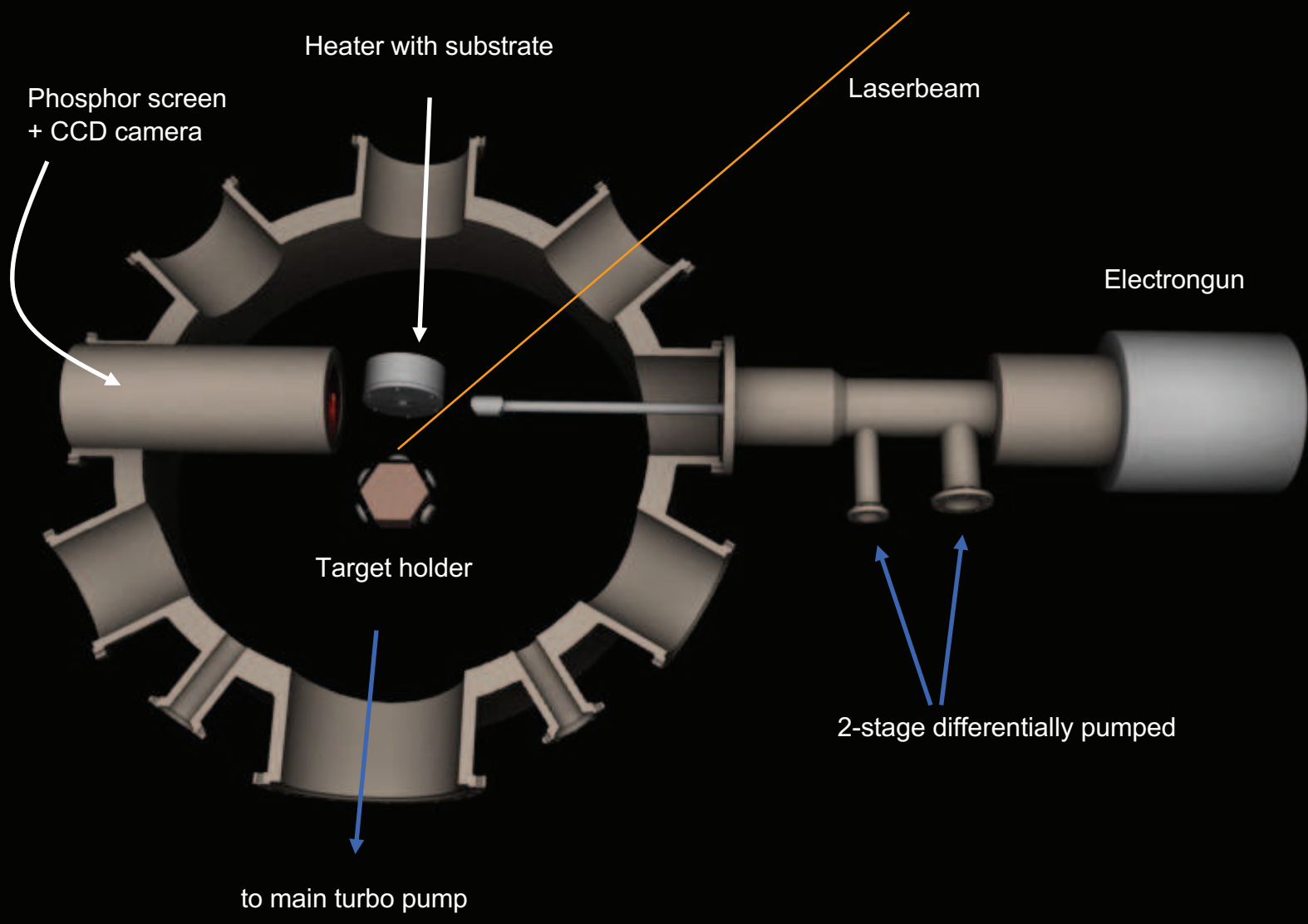




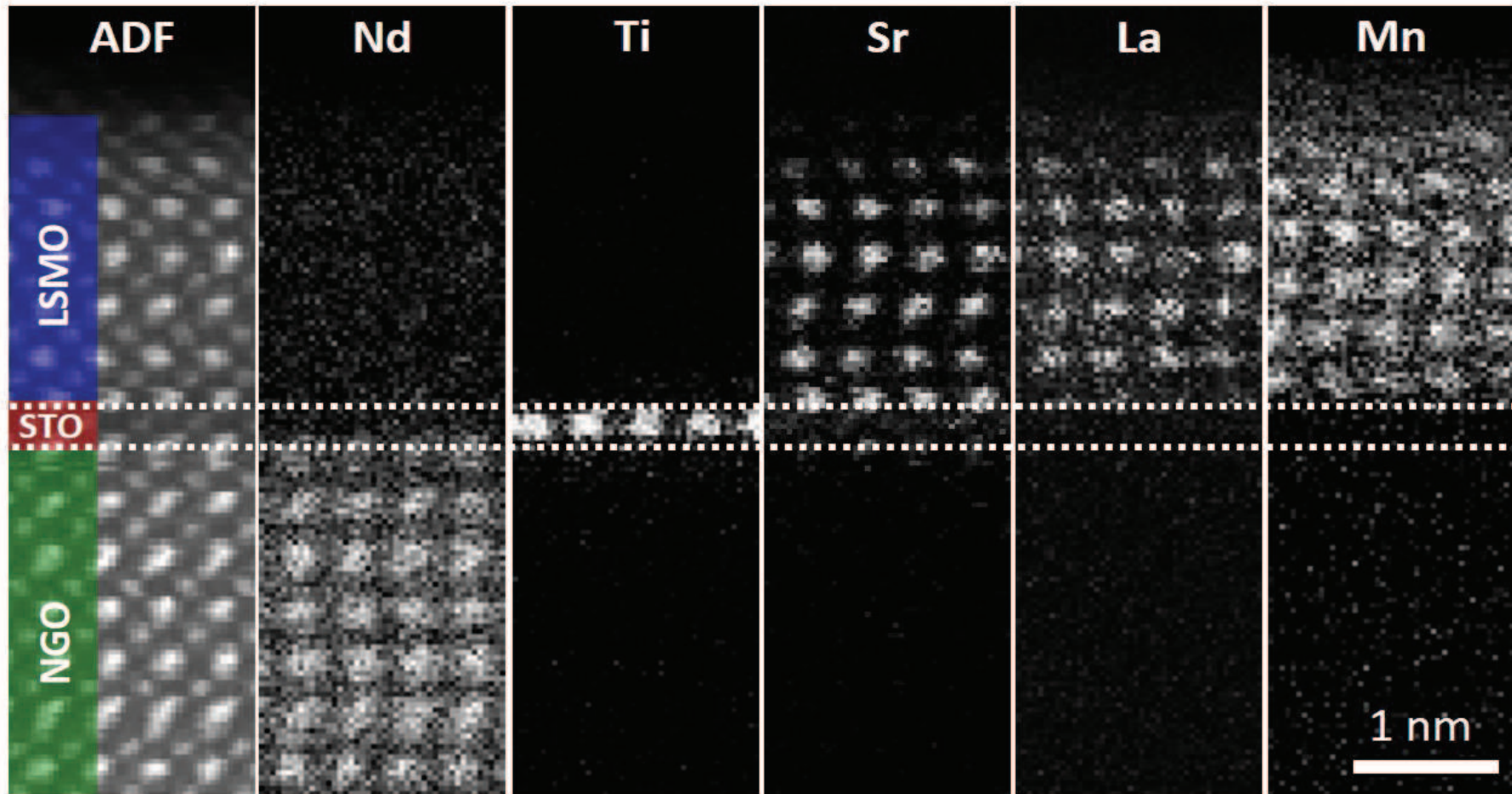
PLD

UPS, XPS,  
XPD

AFM, STM

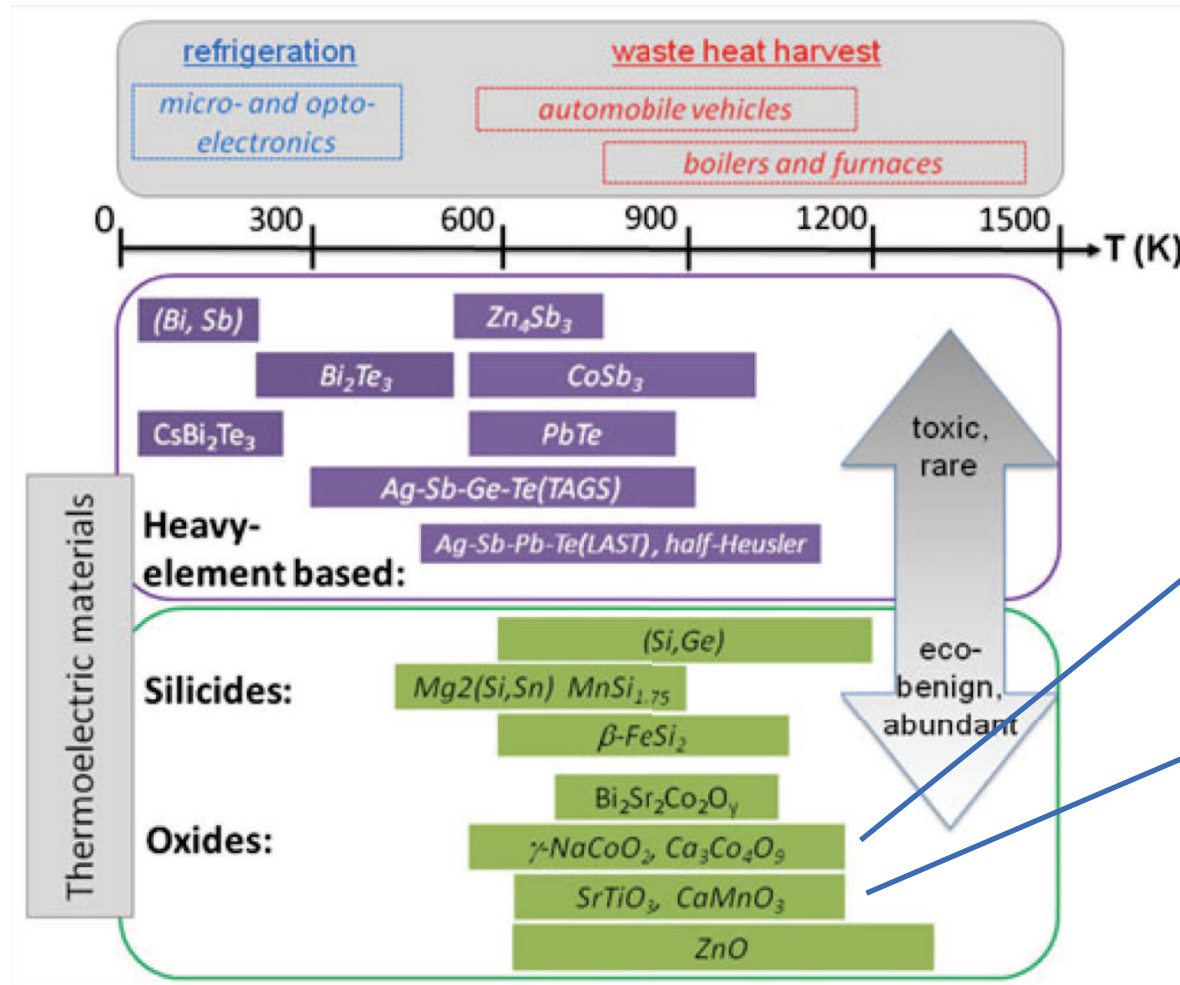


# Atomically controlled thin film growth



Nature Materials 15, 425 (2016)

# Thermoelectric materials



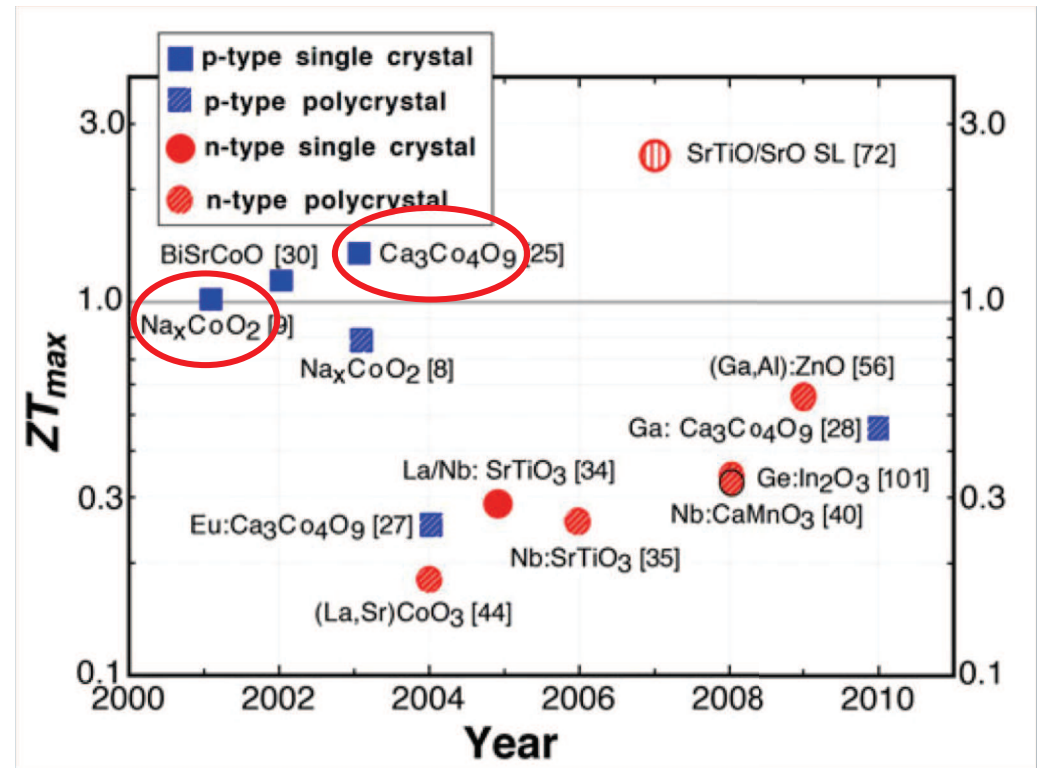
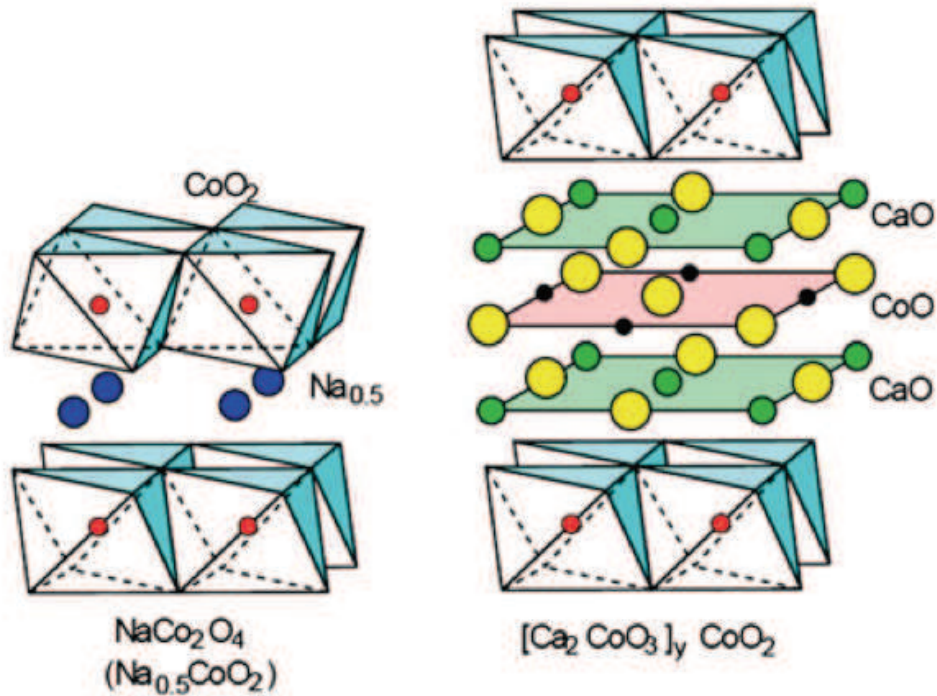
*Appl. Phys. Lett.* **92**, 092118 (2008)  
*Appl. Phys. Lett.* **92**, 191911 (2008)  
*Appl. Phys. Lett.* **92**, 202113 (2008)  
*Chem. Mater.* **22**, 3983–3987 (2010)  
*Appl. Phys. Lett.* **98**, 221904 (2011)  
*Phys. Rev. B* **83**, 035101 (2011)

UNIVERSITY OF TWENTE.



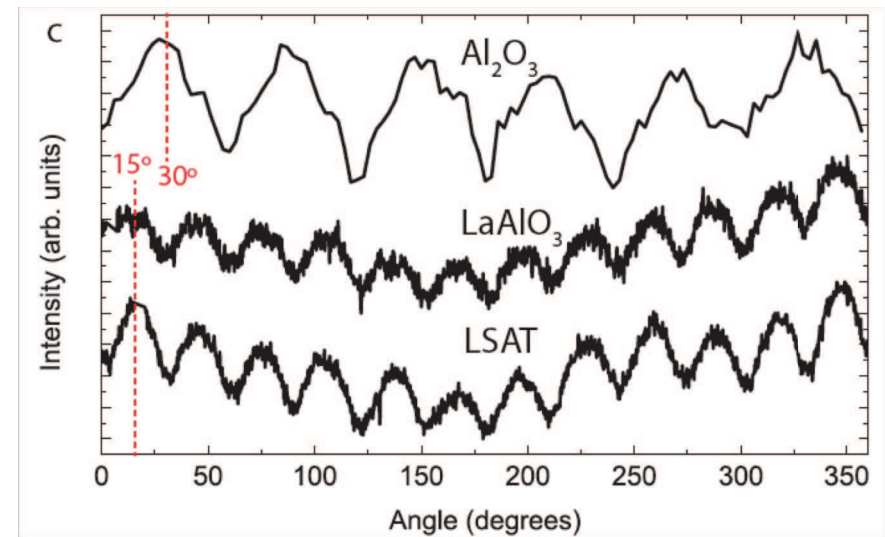
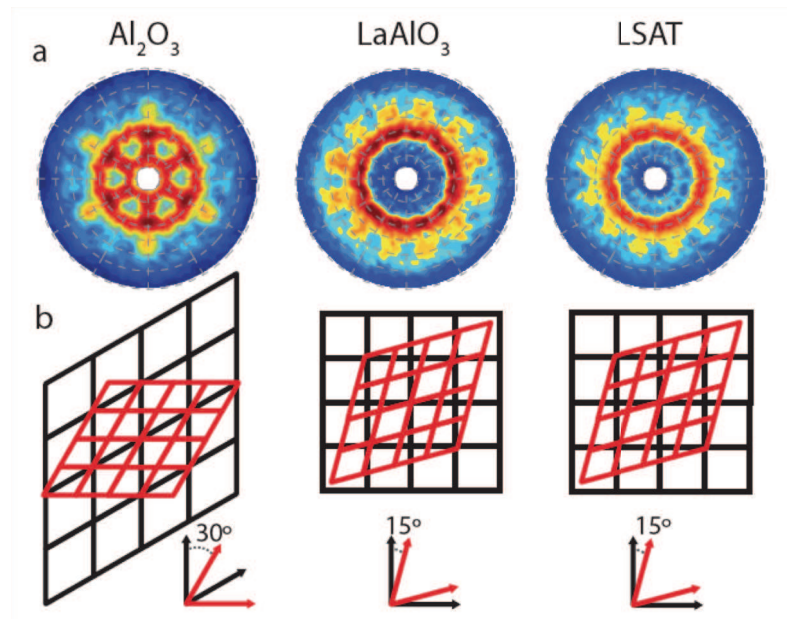
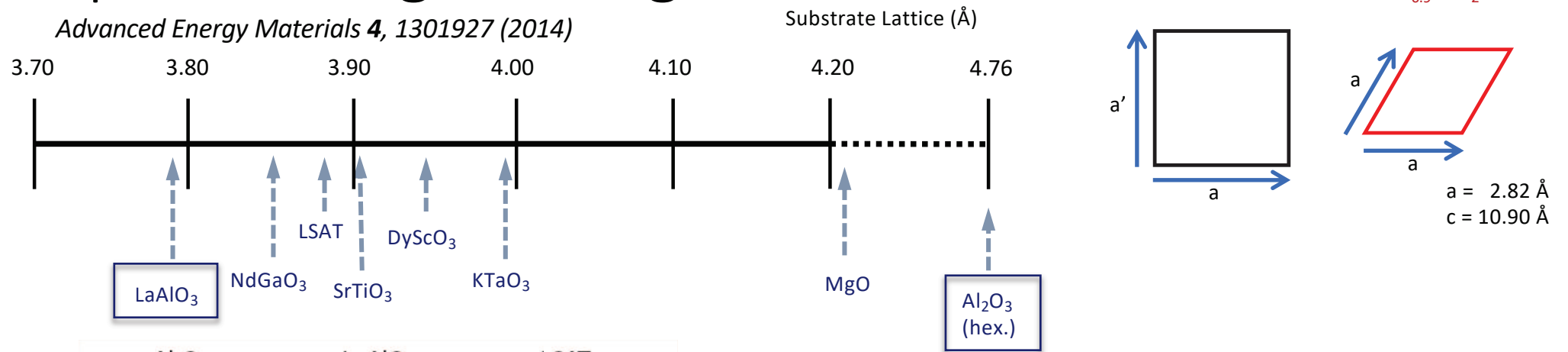


# Layered cobaltites



# Epitaxial engineering

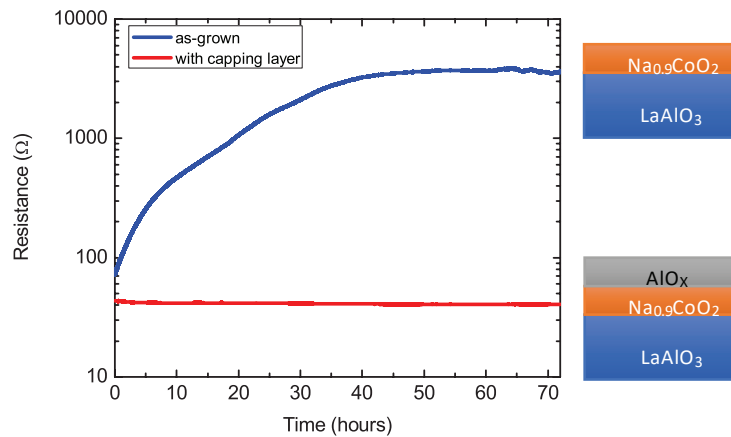
*Advanced Energy Materials* 4, 1301927 (2014)



# Thermoelectric $\text{Na}_x\text{CoO}_2$ thin films

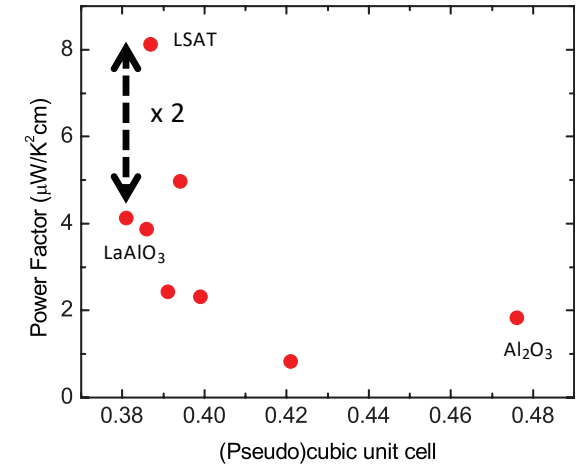
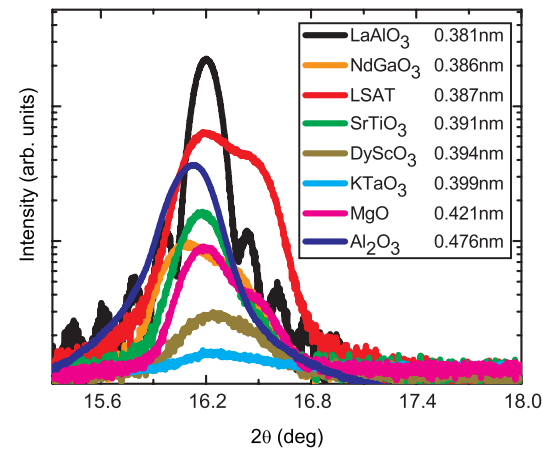
## Enhanced chemical stability

*RSC Advances* **2**, 6023-6027 (2012)



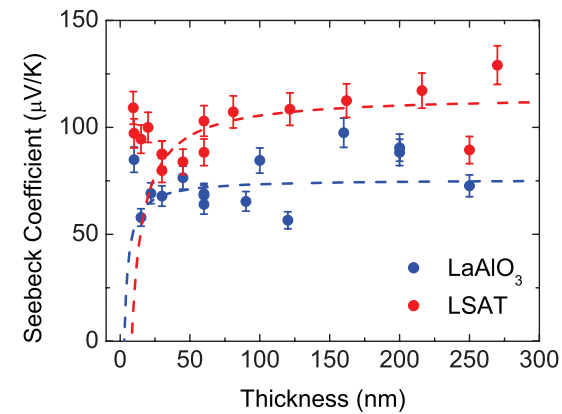
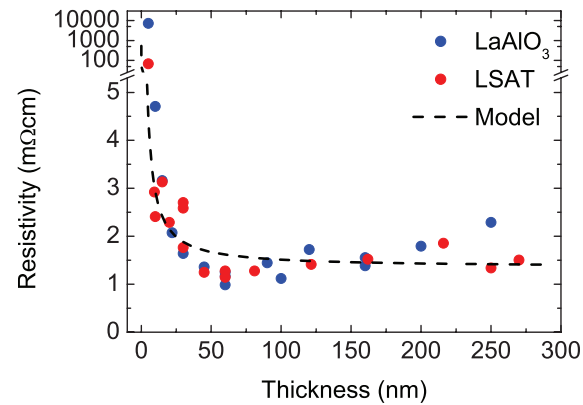
## Enhanced thermoelectric power factor

*Advanced Energy Materials* **4**, 1301927 (2014)



## Thickness dependent size effects

*Appl. Phys. Lett.* **105**, 193902 (2014)

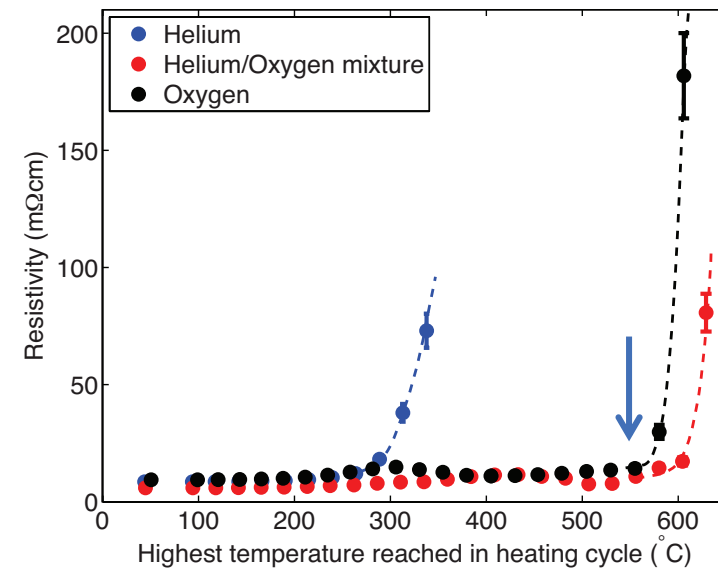
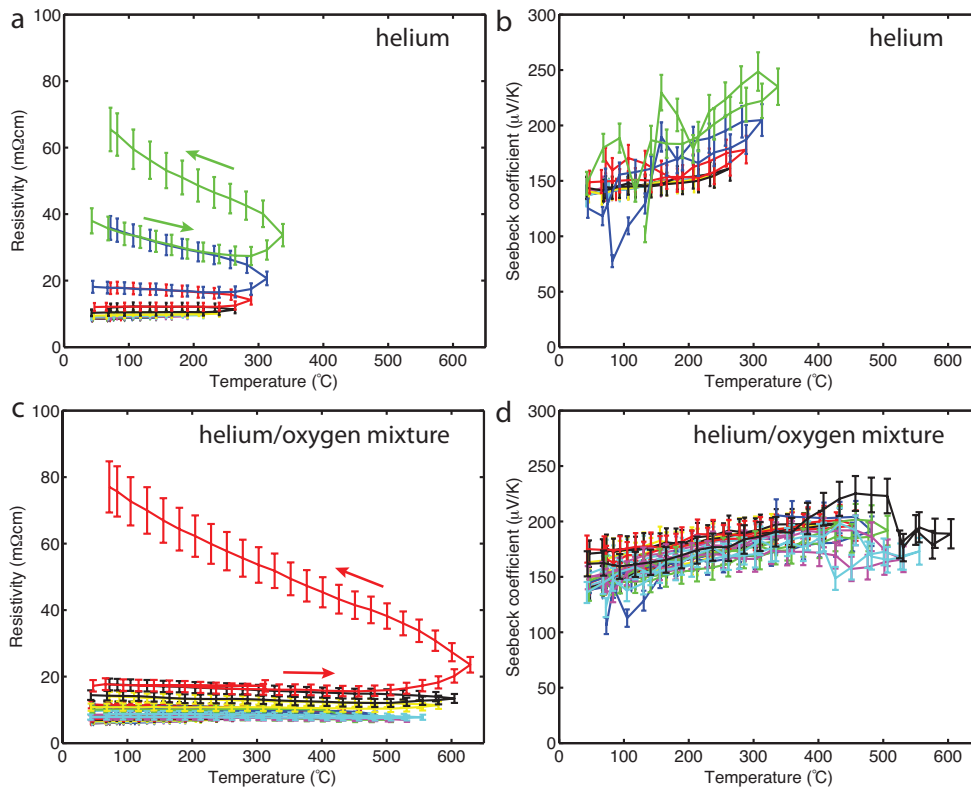


Tellier's and Pichard's models

# Thermoelectric $\text{Ca}_3\text{Co}_4\text{O}_9$ thin films

## High temperature stability

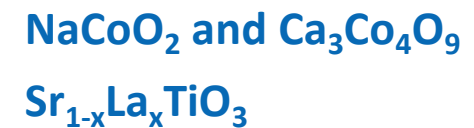
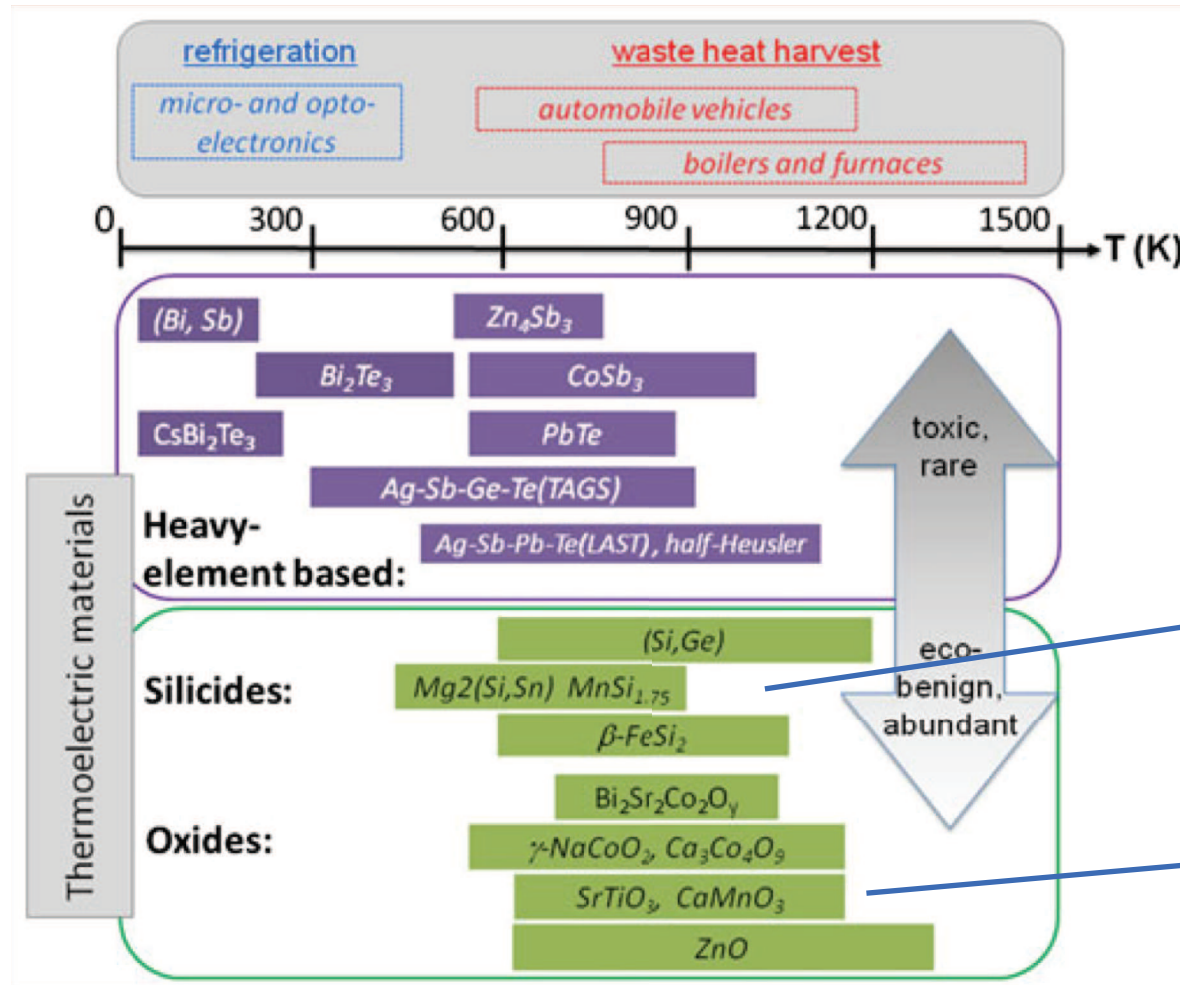
*Appl. Phys. Lett.* **106**, 143903 (2015)



**At 550  $^{\circ}\text{C}$  :**  
7.1  $\text{m}\Omega\cdot\text{cm}$   
192  $\mu\text{V}/\text{K}$   
5.2  $\times 10^{-4} \text{ Wm}^{-1}\text{K}^{-2}$

Bulk CCO:  
3.0  $\times 10^{-4} \text{ Wm}^{-1}\text{K}^{-2}$

# Thermoelectric materials

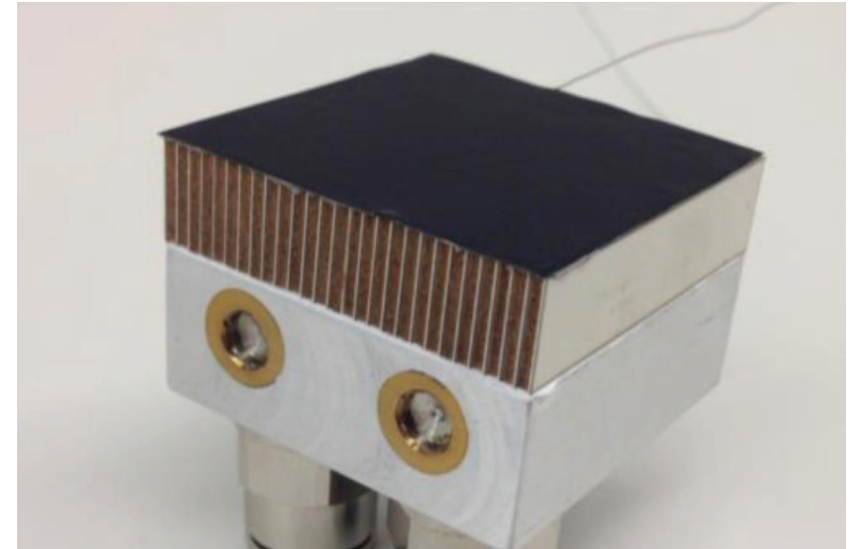
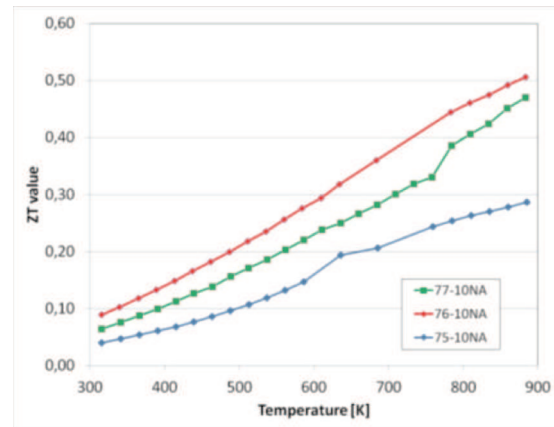
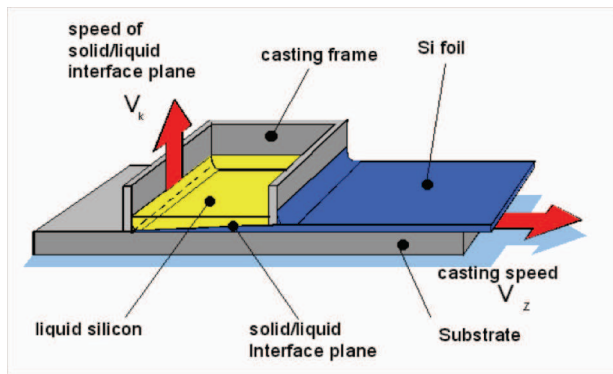


J. He et al., *J. Mater. Res.* **26**, 1762 (2011).

# Higher manganese silicides

Manufacturing of thermoelectric modules

*Materials Today: Proceedings 2, 538 – 547 (2015)*



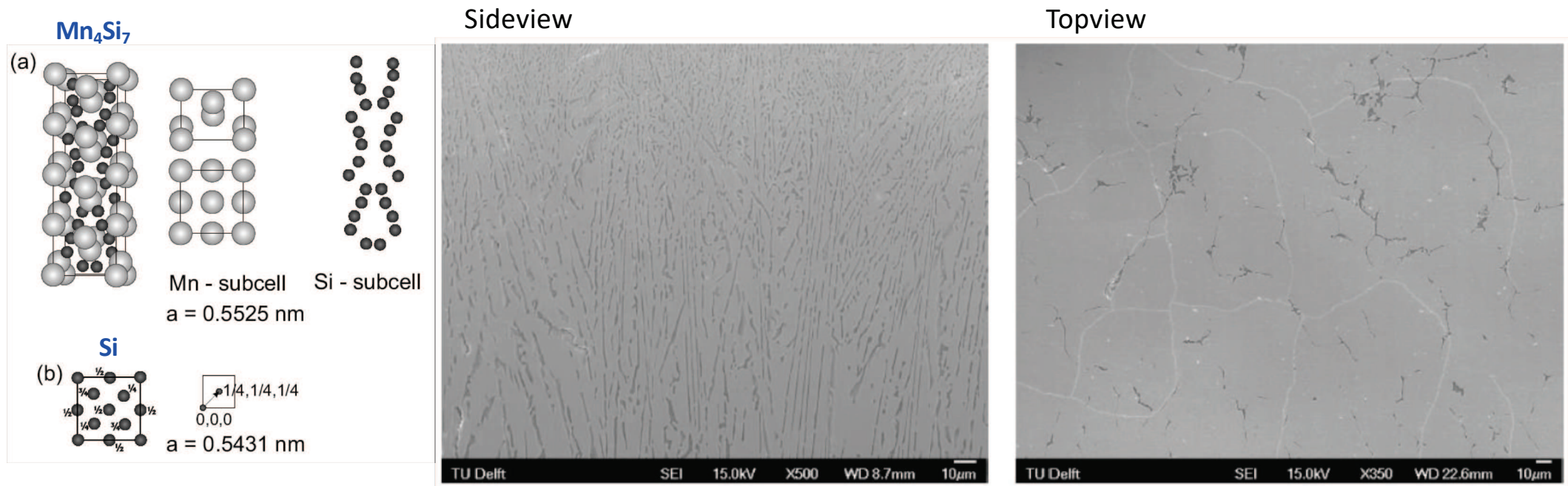
ribbon-growth-on-substrate (RGS) technology



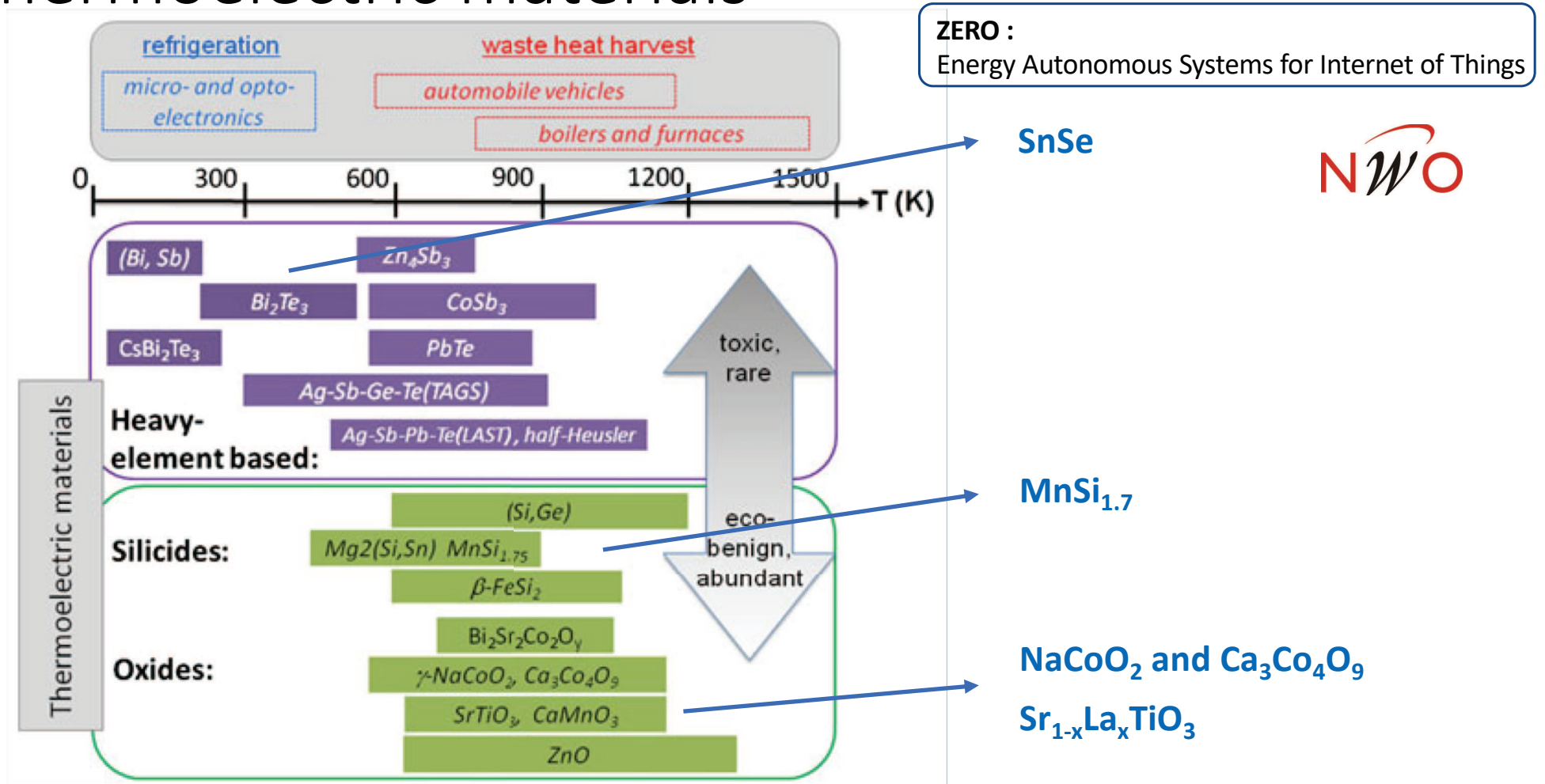
# Higher manganese silicides

Enhanced phonon scattering by phase structuring of Si in HMS phase.

*Materials Today: Proceedings 2, 538 – 547 (2015)*



# Thermoelectric materials



J. He et al., *J. Mater. Res.* **26**, 1762 (2011).



# Autonomous Parking Sensor Networks

## SENSIT IR FLUSH MOUNT NB-IOT

| wireless smart parking sensor

### KEY FEATURES:

- dual detection technology (infrared and magnetic)
- flush mount installation (snowplough resistant\*)
- real-time communication via NB-IoT telecom network
- tool for easy mounting included
- advanced monitoring with SENSIT Interface Software
- easy data integration (API) with third party applications

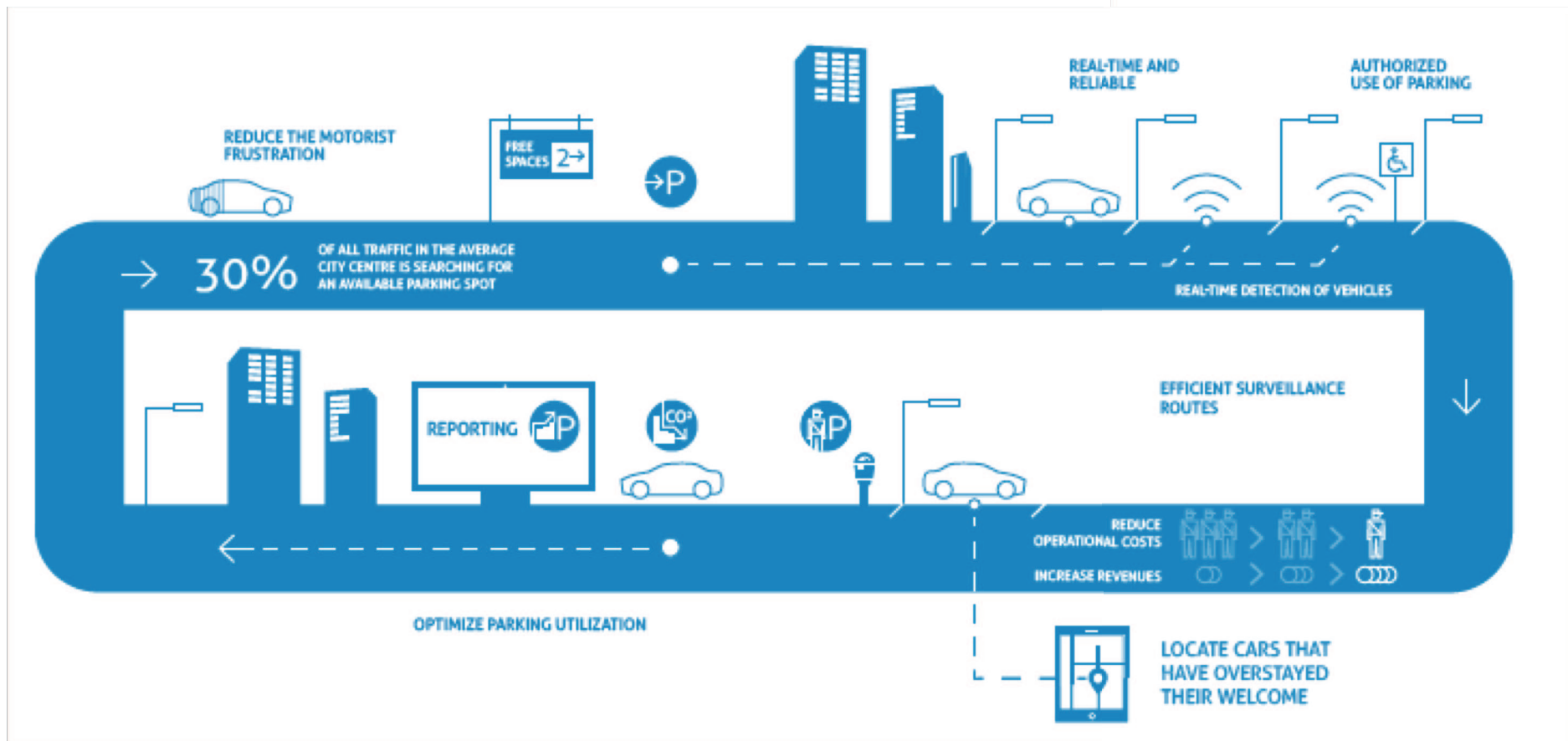


 nedap | mobility solutions

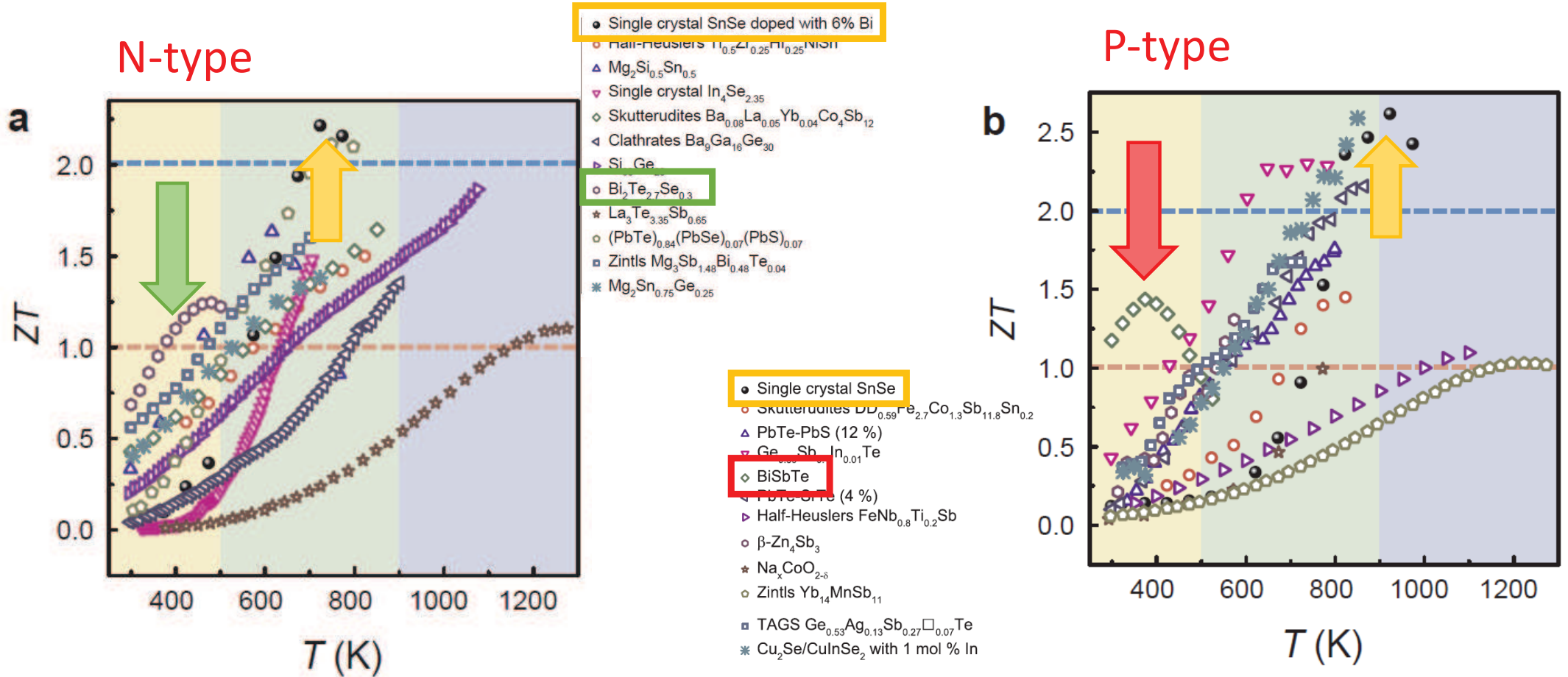


# Autonomous Parking Sensor Networks

Based on Internet-of-Things (IoT) and 5G-network



# Promising thermoelectric materials



Chen, Z.-G., et al. (2018). Progress in Materials Science **97**: 283-346.

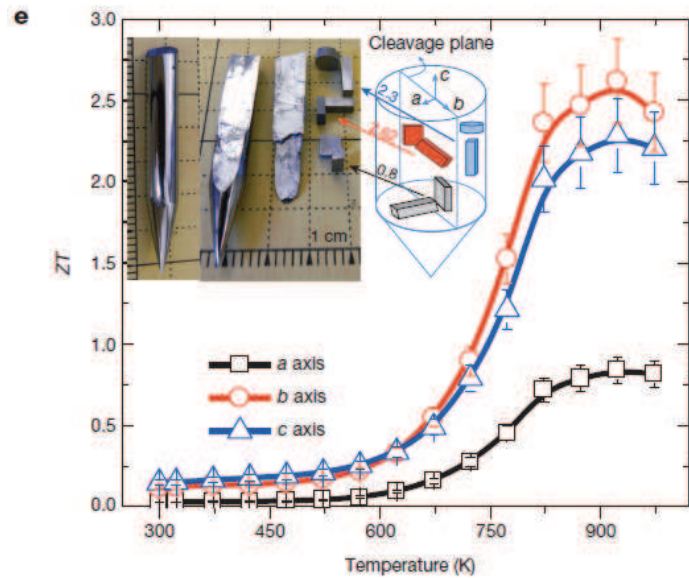
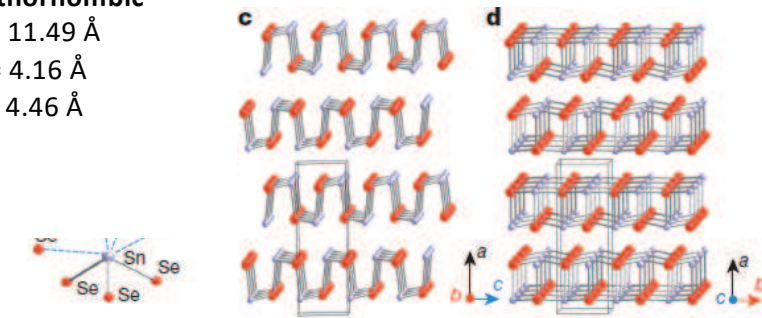
# Tin Selenide (SnSe)

**Orthorhombic**

$a = 11.49 \text{ \AA}$

$b = 4.16 \text{ \AA}$

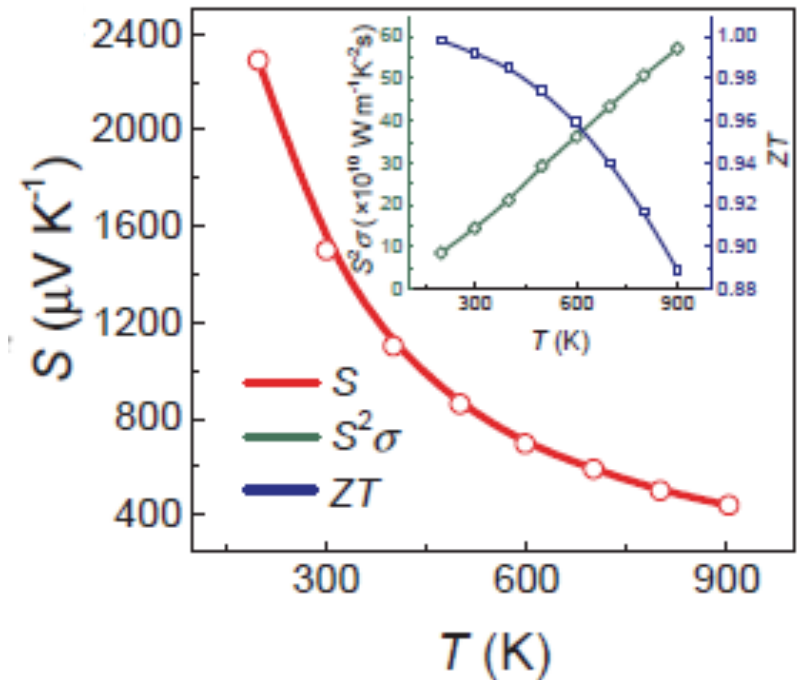
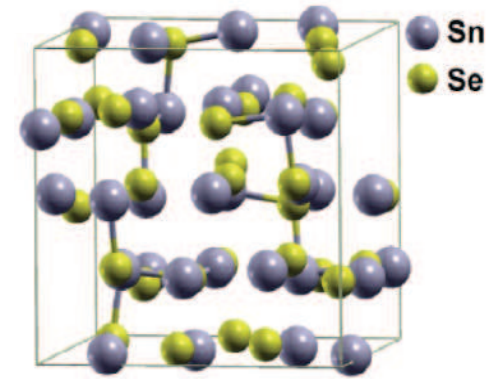
$c = 4.46 \text{ \AA}$



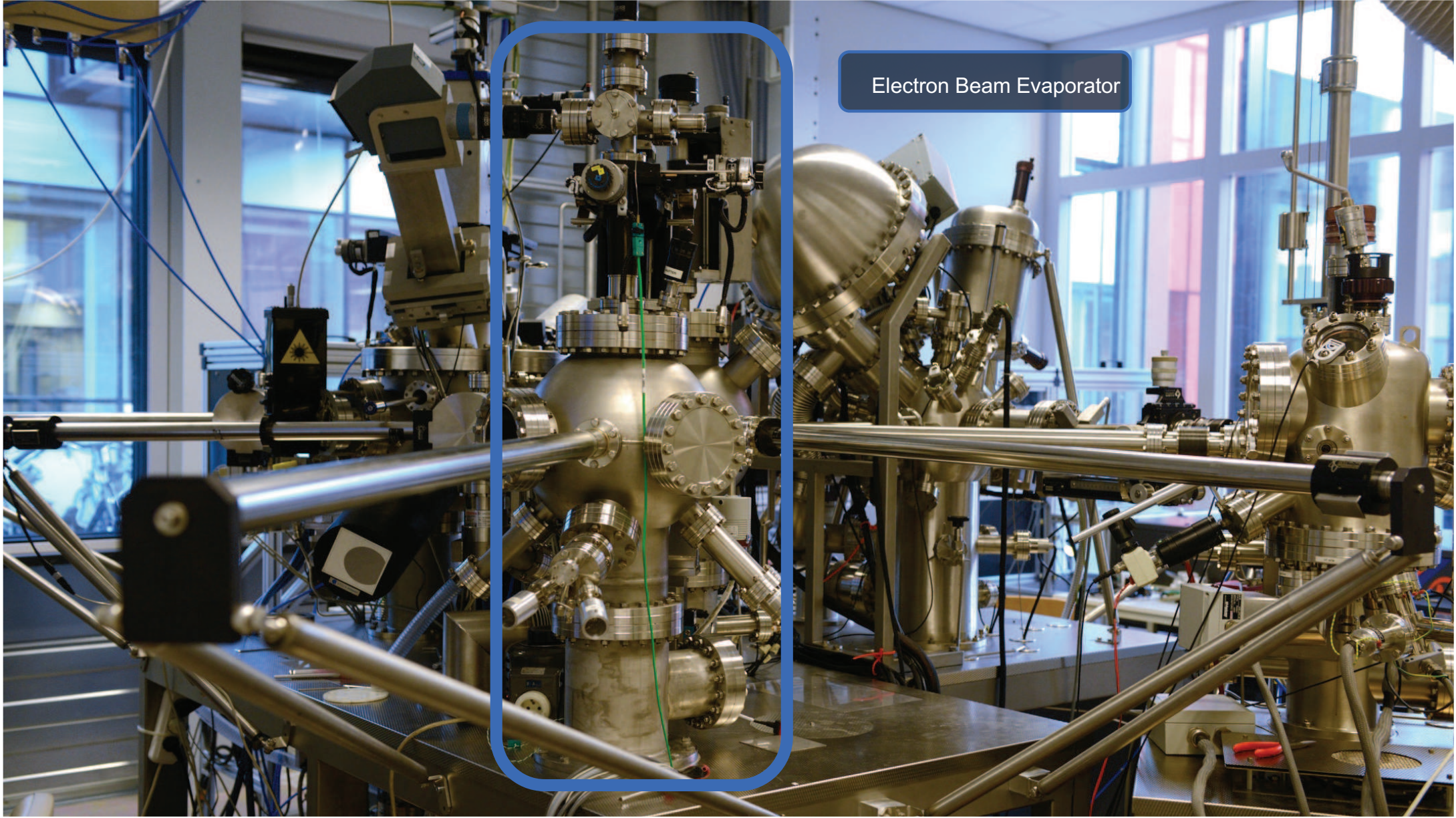
Zhao, L.-D., et al. (2014). *Nature* **508**: 373.

**Cubic**

$a = 11.97 \text{ \AA}$

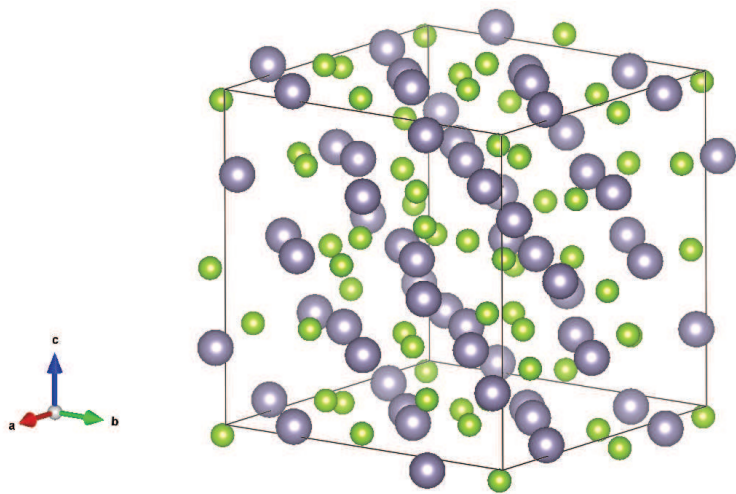


Butt, F. K., et al. (2017). *Journal of Alloys and Compounds* **715**: 438-444.

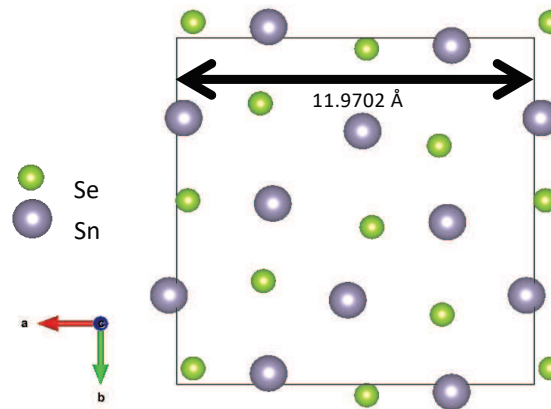


Electron Beam Evaporator

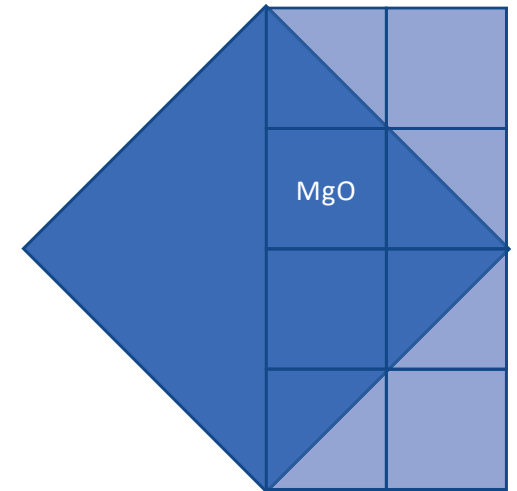
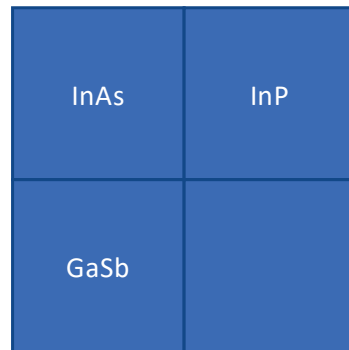
# Epitaxial thin film engineering



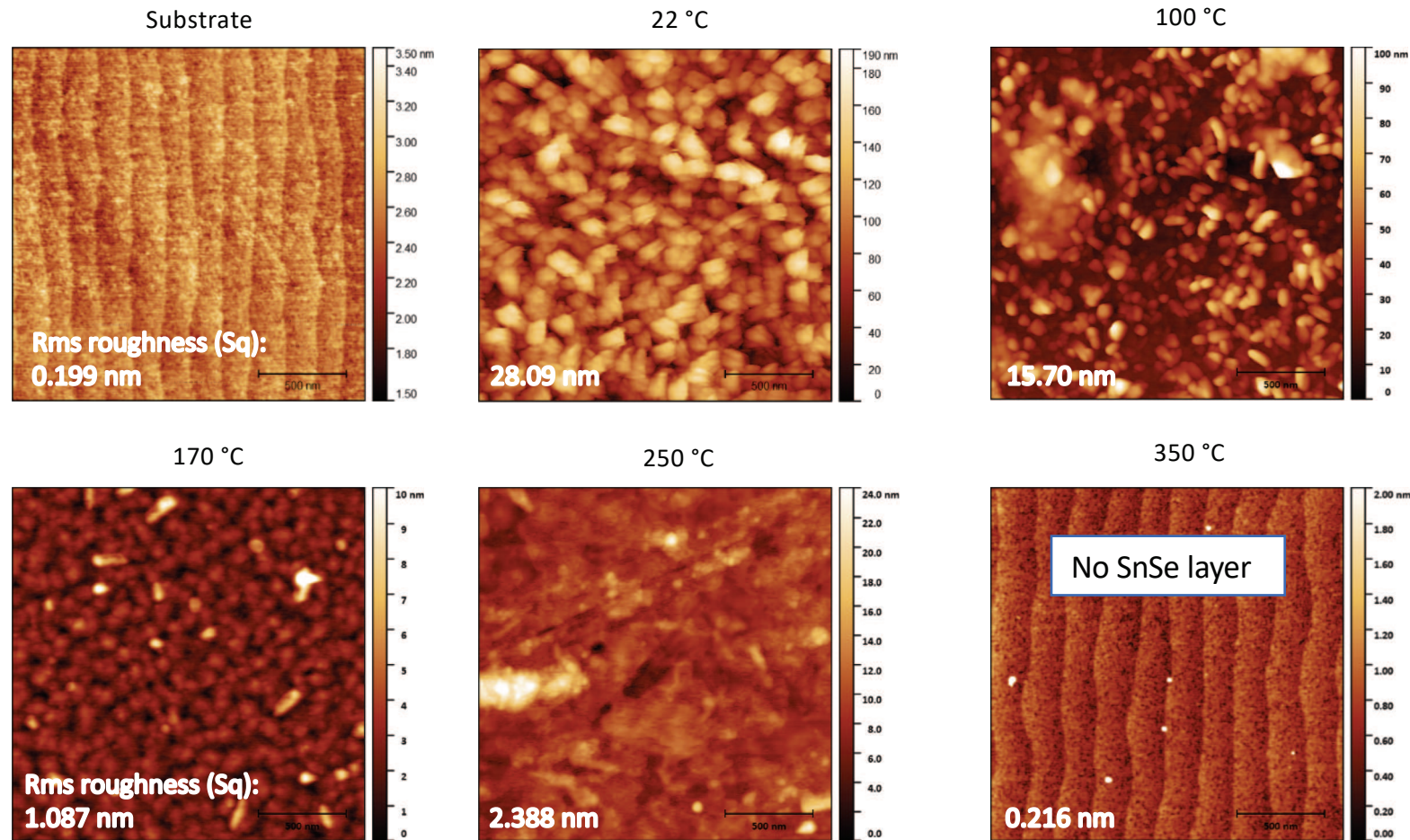
Cubic SnSe – (100) surface



## Promising substrate templates

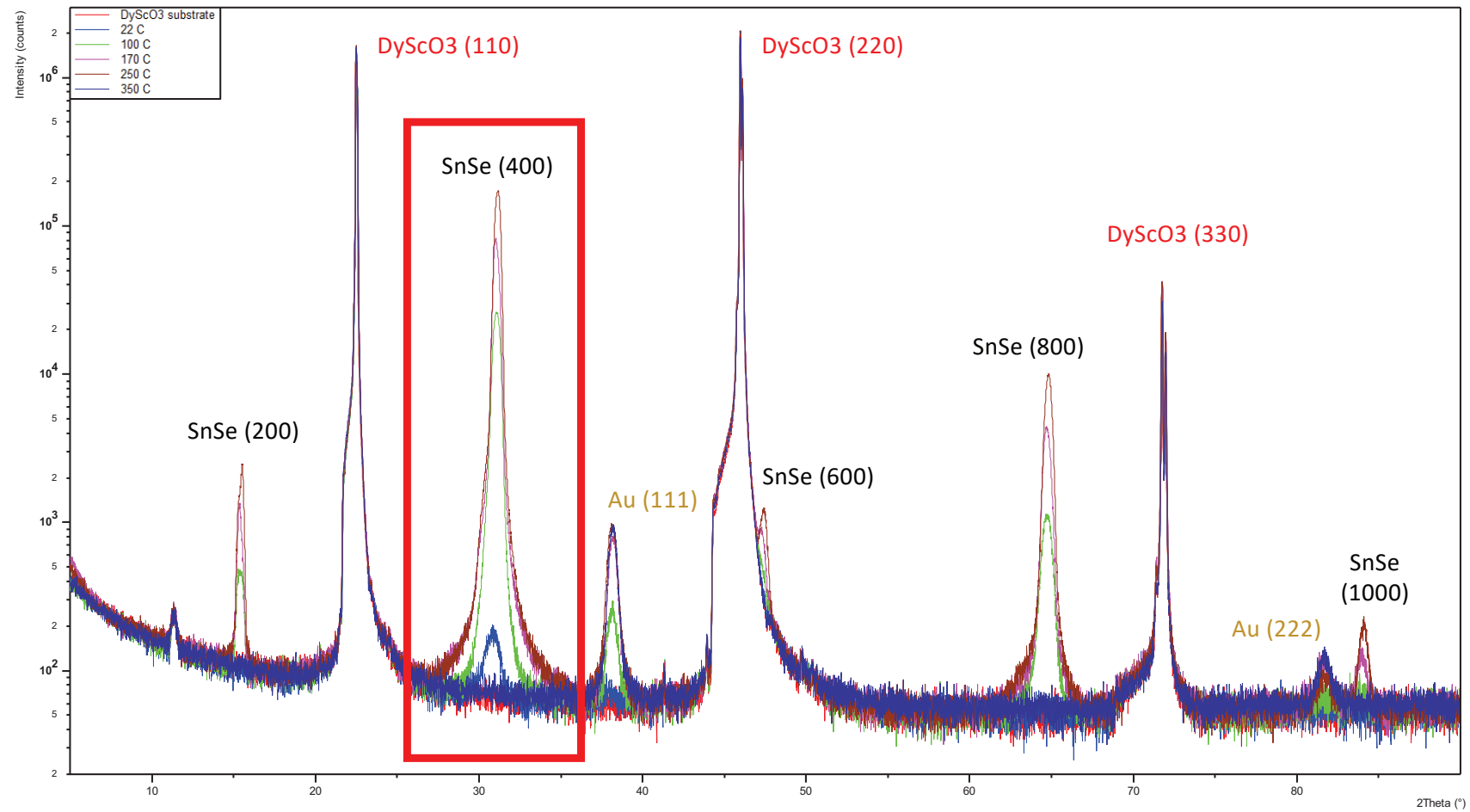


# SnSe thin film growth: temperature dependence



DyScO<sub>3</sub> (110)  
substrate

# SnSe thin film growth: temperature dependence

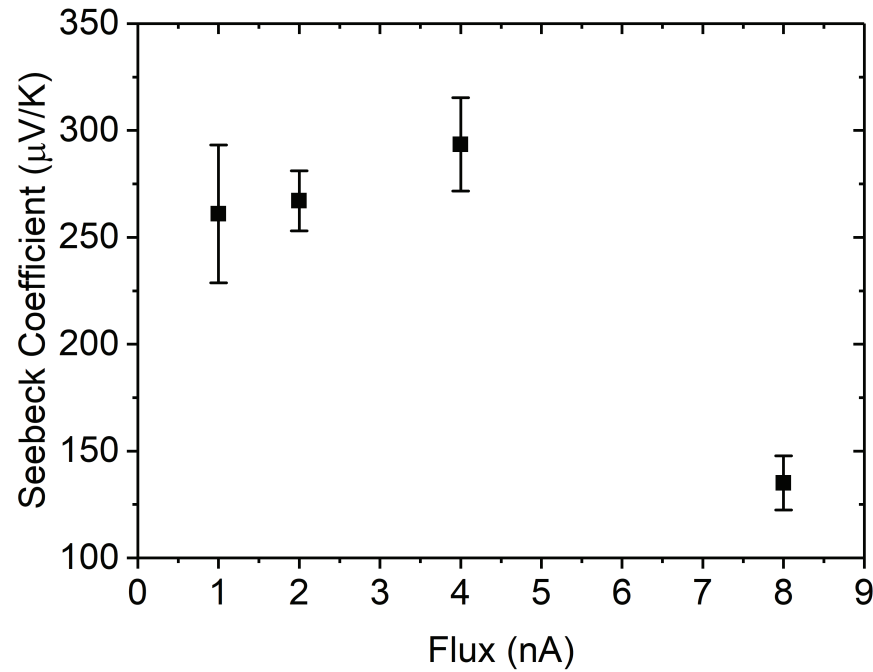




# Thermoelectric Properties

$$ZT = \frac{S^2 \sigma}{\kappa} T$$

## Seebeck Coefficient



$\sigma$

**0.5 - 1.9 S/cm**

This value is comparable to literature

We are currently expanding the measurement capabilities

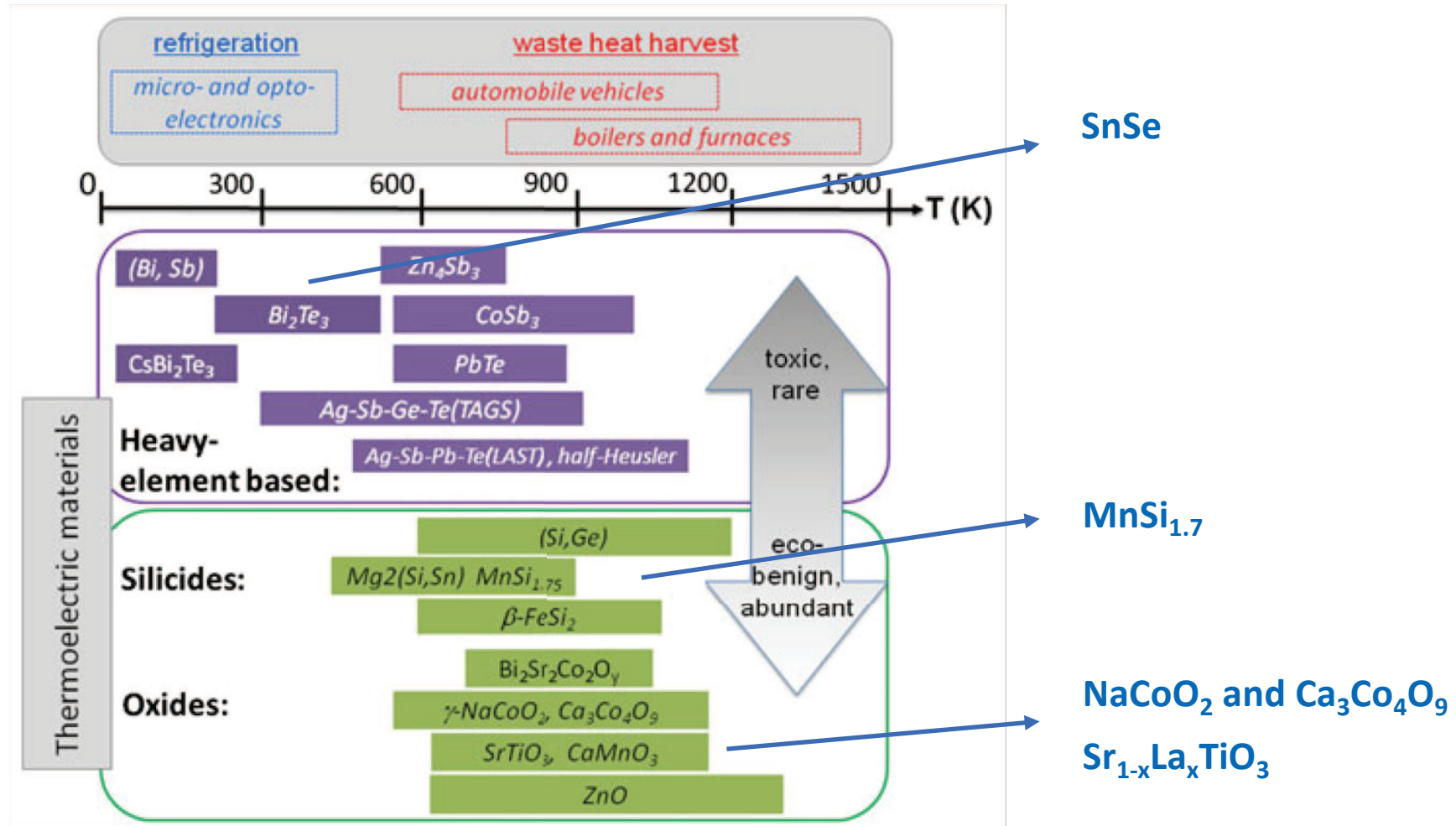
$\kappa$




**Radboud Universiteit**

Time Domain Thermo Reflectance

# Advanced Thin Film Technology for Thermoelectrics



J. He et al., *J. Mater. Res.* **26**, 1762 (2011).



**MESA<sup>+</sup>**  
INSTITUTE FOR NANOTECHNOLOGY

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Thank you